

S/N TBD
Docket: CS02-090
Group art unit : __ TBD

Date October 1, 2003

To: **Commissioner of Patents and Trademarks**
P.O. Box 1450 Alexandria, VA 22313-1450

Fr: **William J. Stoffel Reg. No. 39,390 Cust No. 30402**
PMB 455
1735 Market St - Suite A
Philadelphia, PA 19103

Subject:

Serial No. TDB
Docket cs02-090
File Date: with application
Inventor: Yang et al.

title: Method for forming a MIM capacitor

Group art unit: TBD

INFORMATION DISCLOSURE STATEMENT

Enclosed is Form PTO A820 (also PTO-1449), Information Disclosure Citation and references.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450, on oct 2 , 2003.

Signature/Date W J Stoffel 10/2/03
William J. Stoffel Reg. No. 39,390
Customer number 30402

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The following Patents and/or Publication are submitted to comply with the duty to disclose under CFR 1.97-1.99 and 37 CFR 1.56.

US 6,387,750B1(Lai et al.) shows a process for a MIM capacitor.

US 6,559,004b1(Yang et al.) shows a process for forming a MIM capacitor.

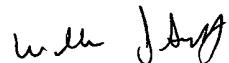
US 6,468,873b1(Lui et al) shows a CU MIM process.

US 2002/0019123A1 - Ma et al. discloses a Cu MIM process.

US 6,426,250 (Lee,et al.) shows a High density stacked MIM capacitor structure.

US 6,451,650 (Lou) discloses a Low thermal budget method for forming MIM capacitor.

Sincerely,



William J. Stoffel
Reg. No. 39,390
Customer number 30,402

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)
Cs02-090

Application Number

Applicant(s)
Tang et al.

Filing Date

tbd

Group Art Unit

tbd

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		US 6,387,750B1		Lai et al.)			
		US 6,559,004b1		Yang et al.)			
		US 6,468,873b1		Lui et al			
		US 2002/0019123A1		Ma et al			
		US 6,426,250		Lee,et al.)			
		US 6,451,650		Lou			

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.